W 7-13-00 Mmd+ #17/C



35.C11946

# PATENT APPLICATION

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Examiner: C. Dexter

AKIRA FUNAKOSHI, ET AL.

Art Unit 3724

Application No.: 08/801,464

Filed: February 18, 1997

For: SUBSTRATE CUTTING METHOD

AND SUBSTRATE CUTTING

**APPARATUS** 

July 10, 2000

(Monday)

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The Commissioner for Patents Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment and Response to Ex Parte Quayle in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below:

			CLAIMS AS AM	ENDED		
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	34	MINUS	34	= 0	x \$9 \$18	\$ 0.00
INDEP. CLAIMS	6	MINUS	6	= 0	x \$39 \$78	\$ 0.00
Fee for Multiple Dependent claims \$130°/\$260						\$
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ 0.00

	°Verified Statement claiming sonot filed previously.	mall entity status is enclosed, if				
	A check in the amount of \$	is enclosed.				
	Charge \$ to Deposit Acc this sheet is enclosed.	ount No. 06-1205. A duplicate of				
х	CFR 1.18 to Deposit Account No Commissioner is hereby authori under 37 CFR 1.16 and 1.17 whi	n to charge an issue fee under 37.06-1205 is hereby revoked. The zed to charge any additional fees ch may be required during the entire or to credit any overpayment, to A duplicate of this paper is				
	A check in the amount of \$extension is enclosed.	to cover the fee for a month				
	A check in the amount of \$					
x	Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.					
		Respectfully submitted,				
30 Roc New Yo	TRICK, CELLA, HARPER & SCINTO kefeller Plaza rk, New York 10112-3801 ile: (212) 218-2200	Attorney for Applicants Registration No. 33,326				

SEW:rle



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The Commissioner for Patents					
Washington, D.C. 20231					
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### AMENDMENT AND RESPONSE TO EX PARTE QUAYLE

Sir:

In response to the Office Action dated May 8, 2000, please amend the above-identified application as follows:

# IN THE SPECIFICATION:

Please amend the specification as follows: